

Electronic Patent Application Fee Transmittal

Application Number:	10626675			
Filing Date:	25-Jul-2003			
Title of Invention:	Epitaxial wafer production apparatus and susceptor structure			
First Named Inventor/Applicant Name:	Hidemasa Kai			
Filer:	Darrin A. Auito/Robin Rothwell			
Attorney Docket Number:	030901			
Filed as Large Entity				
Utility under 35 USC 111(a) Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 2 months with \$120 paid	1252	1	370	370

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	810	810
Total in USD (\$)				1180